

212812US-2524-57-2



IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF :

TAKASHI IPPOSHI ETAL. : GROUP ART UNIT: 2815

SERIAL NO: 09/930,202 : EXAMINER: JOSEPH NGUYEN

FILED: AUGUST 16, 2001 :

FOR: SEMICONDUCTOR WAFER

RECEIVED
JUL 29 2002
TECHNOLOGY CENTER 2800

LETTER REQUESTING APPROVAL OF DRAWING CHANGES

ASSISTANT COMMISSIONER FOR PATENTS
WASHINGTON, D.C. 20231

SIR:

Please review for approval the proposed changes to the Formal Drawings shown in
RED on the attached photocopies of the drawings.

Once these changes have been reviewed and approved by the Examiner in charge of
this case, instructions for their implementation will be forwarded to an approved bonded
draftsman.

Respectfully submitted,

OBLON, SPIVAK, McCLELLAND,
MAIER & NEUSTADT, P.C.

Gregory J. Maier
Attorney of Record
Registration No. 25,599
W. Todd Baker
Registration No. 45,265



22850

(703) 413-3000

Fax No.: (703)413-2220

I:\atty\Wtb\2524\2121812 Ltr Draftsperson 23May02.wpd